

PATENT APPLICATION
Docket No.: 2522-047
Client Ref. No.: AW8085US/EK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Deok-Yong KIM, et al.

Serial No.:	10/749,670	Examiner:	Rosario, Dennis
Filed:	December 30, 2003	Group Art Unit:	2624
Confirmation No.:	9761		
For:	METHOD AND APPARATUS FOR DETECTING DEFECTS ON A WAFER		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 20070518, dated May 31, 2007, please amend the application as follows.

- **Amendments to the Specification** begin on page 2 of this paper.
- **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.
- **Remarks/Arguments** begin on page 7 of this paper.